JUN 2 6 2006 8

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:)	Group Art Unit: 2818
Shunpei YAMAZAKI et al.)	Examiner: Ngan V. Ngo
Serial No. 09/466,828)	CERTIFICATE OF MAILING I hereby certify that this correspondence is being deposited with the United States Posta Service with sufficient postage as First Class Mail in an envelope addressed to Commissioner for Patents, P.O. Box 1450
Filed: December 20, 1999)	
For: INSULATING FILM AND METHOD)	
OF PRODUCING SEMICONDUCTOR)	Alexandria, VA 22313-1450, on June 23 2006.
DEVICE)	adel M Stamper

SUPPLEMENTAL AMENDMENT

Honorable Commissioner of Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Further to the *Response* filed May 9, 2006, please consider the following amendments and remarks in connection with the above-identified application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 9 of this paper.

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